



503.36911X00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): T. ONO, et al

Serial No.: 09/249,292

Filed: February 12, 1999

For: METHOD AND APPARATUS FOR TREATING SURFACE OF SEMICONDUCTOR

Group: 1746

Examiner: A. Alanko

8/3  
10-24-00

AMENDMENT

Commissioner for Patents  
Washington, D.C. 20231

October 19, 2000

Sir:

The following amendments and remarks are respectfully submitted in connection with the above-identified application in response to the Office Action dated October 3, 2000.

IN THE CLAIMS:

Please cancel claims 8-23 without prejudice or double claim of the subject matter thereof, such claims being subject to a restriction requirement.

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REMARKS

In response to the requirement for election of one of the inventions identified as invention I - claims 1-7; invention

II - claims 8-13; invention III - claims 14-17; and invention IV - claims 18-23, applicants elect invention I - claims 1-7.

In view of the above election, applicants have canceled claims 8-23 from this application and intend to submit a divisional application directed thereto.

In view of the above election, favorable action with respect to claims 1-7 is requested.

To the extent necessary, applicant's petition for an extension of time under 37 CFR 1.136. Please charge any shortage in the fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account No. 01-2135 (503.36911X00) and please credit any excess fees to such deposit account.

Respectfully submitted,



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